



**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Masashi UEDA et al.

Group Art Unit: 1763

Application No.: 09/830,879

Examiner: P. Hassanzadeh

Filed: May 2, 2001

Docket No.: 109426

For: INTERNAL ELECTRODE TYPE PLASMA PROCESSING APPARATUS AND  
PLASMA PROCESSING METHOD

**SUBMISSION UNDER 37 CFR §1.114**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In further reply to the April 16, 2003 Final Office Action, and further to the July 10, 2003 Request for Reconsideration, the July 11, 2003 personal interview between Applicants' representative and Examiner Hassanzadeh, the July 16, 2003 Amendment After Final Rejection, the July 21 and 24, 2003 Advisory Actions, and the July 22 and August 13, 2003 telephone interviews, the shortened statutory period for reply being extended by the attached Petition for Extension of Time, please amend the above-identified application with sections as follows:

**Amendments to the Specification;**

**Amendments to the Claims** are reflected in the listing of claims;

**Amendments to the Drawings** include an attachment sheet; and

**Remarks.**